

Practitioner's Docket No.: 327 084

PATENT DEC 13 2008/E

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

December 2, 2002

Rudolf Flosbach Ser. No.: 09/807,154

Art Unit: 2856

Filed:

April 9, 2001

Examiner:

Andre K. Jackson

For: FILM LEAK DETECTOR

Assistant Commissioner for Patents Washington DC 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail addressed to Assistant Commissioner for Patents, Washington D.C. 20231, on December 2, 2002.

Susanne C. Aregano

AMENDMENT

Sir:

In response to the non-Final Official Action, Paper No. 5, dated July 5, 2002, please amend the above-captioned patent application, without prejudice, as follows:

In the Specification:

Please replace the paragraph beginning at page 2, line 20, with the following rewritten paragraph:

The forevacuum pump 13 is usefully a single-stage "pump", the forevacuum pump 30 is developed as a two-stage "pump". Pump 30 is equipped with a gas ballast device. With valve 31 open, air (or also inert gas) streams into pump 30.1-

Please replace the paragraph beginning at page 3, line 7, with the following rewritten paragraph:

for depositing the sniffing probe a holder 54 is provided. Such is either fastened on the film leak detector 1 or developed as a separate stand. It comprises a void 55 which, when the probe 51 is deposited, contains the sniffing tip. In addition is provided a sealing ring 56 which seals the void 55 against the handle 52 when the probe 51 is deposited. Succeeding void 55 is a line 57, which communicates across